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A unique dye-decolorizing peroxidase, DyP, from Thanatephorus cucumeris Dec 1: heterologous expression, crystallization and preliminary X-ray analysis

Acta Crystallogr. Sect. D-Biol. Crystallogr. 60 (2004) 149 – 152

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Low-temperature growth of ZnO epitaxial films by metal organic chemical vapor deposition

Appl. Phys. A-Mater. Sci. Process. 78 (2004) 25 – 28

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